

ductruong

\*\*\*\*\* STN Columbus \*\*\*\*\*

FILE 'HOME' ENTERED AT 11:02:50 ON 31 MAR 2008

=> file pnttext

COST IN U.S. DOLLARS

SINCE FILE

TOTAL

ENTRY

SESSION

FULL ESTIMATED COST

0.21

0.21

FILE 'EPFULL' ENTERED AT 11:03:08 ON 31 MAR 2008

COPYRIGHT (C) 2008 European Patent Office / FIZ Karlsruhe

FILE 'FRFULL' ENTERED AT 11:03:08 ON 31 MAR 2008

COPYRIGHT (C) 2008 Univentio

FILE 'GBFULL' ENTERED AT 11:03:08 ON 31 MAR 2008

COPYRIGHT (C) 2008 Univentio

FILE 'PATDPFULL' ENTERED AT 11:03:08 ON 31 MAR 2008

COPYRIGHT (C) 2008 DPMA

FILE 'PCTFULL' ENTERED AT 11:03:08 ON 31 MAR 2008

COPYRIGHT (C) 2008 Univentio

FILE 'RDISCLOSURE' ENTERED AT 11:03:08 ON 31 MAR 2008

COPYRIGHT (C) 2008 Kenneth Mason Publications Ltd.

FILE 'USPATFULL' ENTERED AT 11:03:08 ON 31 MAR 2008

CA INDEXING COPYRIGHT (C) 2008 AMERICAN CHEMICAL SOCIETY (ACS)

FILE 'USPATOLD' ENTERED AT 11:03:08 ON 31 MAR 2008

CA INDEXING COPYRIGHT (C) 2008 AMERICAN CHEMICAL SOCIETY (ACS)

FILE 'USPAT2' ENTERED AT 11:03:08 ON 31 MAR 2008

CA INDEXING COPYRIGHT (C) 2008 AMERICAN CHEMICAL SOCIETY (ACS)

=> s electrically conductive macromolecule# and monomer# and oxidizing agent#

L1 1 ELECTRICALLY CONDUCTIVE MACROMOLECULE# AND MONOMER# AND OXIDIZIN  
G AGENT#

=> s electrically conductive and macromolecule# and monomer# and oxidizing agent#

L2 217 ELECTRICALLY CONDUCTIVE AND MACROMOLECULE# AND MONOMER# AND OXID  
IZING AGENT#

=> d 11

L1 ANSWER 1 OF 1 USPATFULL on STN

AN 2006:99595 USPATFULL

TI Method and apparatus for producing conductive polymer

IN Yoshida, Tsunenori, Yawata-shi, JAPAN

PA MATSUSHITA ELECTRIC INDUSTRIAL CO., LTD., Osaka, JAPAN, 571-8501  
(non-U.S. corporation)

PI US 2006084768 A1 20060420

AI US 2004-541484 A1 20040517 (10)

WO 2004-JP6994 20040517

20050706 PCT 371 date

PRAI JP 2003-145347 20030522

DT Utility

FS APPLICATION

ductruong

LN.CNT 679  
INCL INCLM: 526/062.000  
INCL: 526/072.000  
NCL NCLM: 526/062.000  
NCL: 526/072.000  
IC IPCI C08F0002-00 [I,A]  
IPCR C08F0002-00 [I,A]; C08F0002-00 [I,C]; C08G0061-00 [I,C\*];  
C08G0061-12 [I,A]; C08G0085-00 [I,C\*]; C08G0085-00 [I,A];  
H01G0009-00 [I,C\*]; H01G0009-00 [I,A]; H01G0009-02 [I,C\*];  
H01G0009-02 [I,A]; H01G0009-022 [I,C\*]; H01G0009-028 [I,A];  
H01G0009-15 [I,C\*]; H01G0009-15 [I,A]  
CAS INDEXING IS AVAILABLE FOR THIS PATENT.

=> s l2 and supersaturated steam atmosphere#

L3 1 L2 AND SUPERSATURATED STEAM ATMOSPHERE#

=> s (pyrrole# or thiophene# or ethylenedioxythiophene# or aniline#) and (oxidizing agent# or manganese oxide# or iron salt# or copper salt# or hydrogen peroxide or persulfate salt#)

7 FILES SEARCHED...

L4 46086 (PYRROLE# OR THIOPHENE# OR ETHYLENEDIOXYTHIOPHENE# OR ANILINE#)  
AND (OXIDIZING AGENT# OR MANGANESE OXIDE# OR IRON SALT# OR COPPER  
R SALT# OR HYDROGEN PEROXIDE OR PERSULFATE SALT#)

=> s l4 and supersaturated steam atmosphere#

L5 1 L4 AND SUPERSATURATED STEAM ATMOSPHERE#

=> d l5

L5 ANSWER 1 OF 1 USPATFULL on STN  
AN 2006,99595 USPATFULL  
TI Method and apparatus for producing conductive polymer  
IN Yoshida, Tsunenori, Yawata-shi, JAPAN  
PA MATSUSHITA ELECTRIC INDUSTRIAL CO., LTD., Osaka, JAPAN, 571-8501  
(non-U.S. corporation)  
PI US 2006084768 A1 20060420  
AI US 2004-541484 A1 20040517 (10)  
WO 2004-JP6994 20040517  
20050706 PCT 371 date

PRAI JP 2003-145347 20030522

DT Utility  
FS APPLICATION

LN.CNT 679

INCL INCLM: 526/062.000  
INCL: 526/072.000  
NCL NCLM: 526/062.000  
NCL: 526/072.000  
IC IPCI C08F0002-00 [I,A]  
IPCR C08F0002-00 [I,A]; C08F0002-00 [I,C]; C08G0061-00 [I,C\*];  
C08G0061-12 [I,A]; C08G0085-00 [I,C\*]; C08G0085-00 [I,A];  
H01G0009-00 [I,C\*]; H01G0009-00 [I,A]; H01G0009-02 [I,C\*];  
H01G0009-02 [I,A]; H01G0009-022 [I,C\*]; H01G0009-028 [I,A];  
H01G0009-15 [I,C\*]; H01G0009-15 [I,A]  
CAS INDEXING IS AVAILABLE FOR THIS PATENT.

=>